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Attorney's Docket No. 4341P053

Patent

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In Re Patent Application of:

Scott Adams et al.

Application No.: 09/775,491

Filed: February 2, 2001

For: ELECTROSTATIC ACTUATOR FOR
MICROELECTROMECHANICAL
SYSTEMS AND METHODS OF
FABRICATION

Examiner: Not Yet Assigned

Art Unit: 3662

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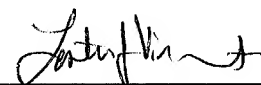
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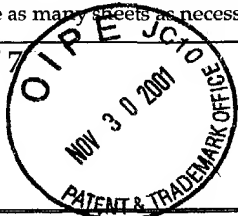
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Page 1 of 7	First Named Inventor: Scott Adams	
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		Number Code ²	Kind (If known)			
		4,104,086		Bondur et al.	08/01/1978	
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		DE	4224601	A1	Hansmann et al.	01/27/1994		
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		WO	97/04283		Miller et al.	02/06/1997		
		WO	99/36941		Adams et al.	07/22/1999		
		WO	99/36948		Adams et al.	07/22/1999		

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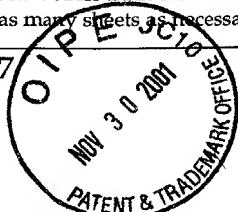
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		WO	01/33898	A2	Ramaswami et al.	05/10/2001		
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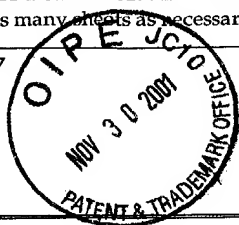
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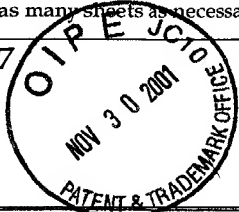
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		Timothy J. Broshnihan, James M. Bustillo, Albert P. Pisano & Roger T. Howe, "Embedded Interconnect & Electrical Isolation for High-Aspect-Ratio, SOI Inertial Instruments," Berkeley Sensor & Actuator Sensor, pp. 637-640, Transducers '97, 1997 International Conference on Solid-State Sensors and Actuators (Chicago, June 16-19, 1997)	
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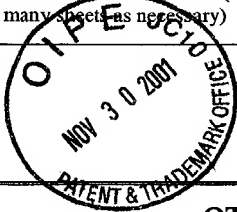
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		Rudolf F. Graf, Radio Shack Dictionary of Electronics, p. 639, Definition of Varibale Capacitor with Picture (1974)	
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		Leslie A. Field, Diane L. Burriesci, Peter R. Robrish, and Richard C. Ruby, "Micromachined 1 X 2 Optical-Fiber Switch," Sensors and Actuators A, 53, pp. 311-315, (1996)	
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		William C. Tang, Martin G. Lim, and Roger T. Howe, "Electrostatic Comb Drive Levitation and Control Method" Journal of Microelectromechanical Systems, Vol. 1, No. 4, pp. 170-178 (December 1992)	
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